MSXP-C Cleanroom / Vacuum / Heat Resistant Couplings - Slit Type (PEEK)













Structure

Clamping Type

MSXP-C → P.xxxx





Property

	MSXP-C
Low Particle	0
Vacuum-supported	0
Low Outgas	0
Heat-resistance	0
Chemical Resistance	0
Zero Backlash	0
Allowable Misalignment	0
Electrical Insulation	0
Cleanroom Specification	0
Allowable Operating Temperature	−20°C to 80°C

- O: Excellent O: Very good
- This is a resin spring coupling with single-piece construction.
- It can be used in an environment or cleanroom where heat resistance and chemical resistance are required, such as FPD manufacturing equipment.
- PEEK superior in physical and chemical properties is adopted. Outgas quantity is extremely low.
- A plate spring formed by a slit allows eccentricity, angular misalignment, and end-play to be accepted.
- Application

FPD manufacturing device / Semiconductor manufacturing device

Material/Finish



	MSXP-C
Main Body	PEEK (Polyether Ether Ketone)
Hex Socket Head Cap Screw	PEEK (Polyether Ether Ketone)

• PEEK's color may vary depending on the lot or other matters.

• Part number specification

Product

Code Please refer to dimensional table for part number specification.

Please feel free to contact us

Cleanroom washed and packed

Change to Stainless Steel Screw → P.xxxx Not Available

